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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/734,543	12/12/2003	Jin Soo Kim	2013P139	9702	
8791	7590 09/22/2005		EXAMINER		
BLAKELY SOKOLOFF TAYLOR & ZAFMAN 12400 WILSHIRE BOULEVARD			HOANG, QI	HOANG, QUOC DINH	
	SEVENTH FLOOR		ART UNIT	PAPER NUMBER	
LOS ANGE	LES, CA 90025-1030	2818			
			DATE MAILED: 09/22/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/734,543	KIM ET AL.				
Office Action Summary	Examiner	Art Unit				
	Quoc D. Hoang	2818				
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	correspondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w. - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 16(a). In no event, however, may a reply be tin 11 apply and will expire SIX (6) MONTHS from 12 cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).				
Status	•					
	une 2005					
	Responsive to communication(s) filed on <u>27 June 2005</u> . This action is FINAL . 2b) This action is non-final.					
•—	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
• -	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Glosed in absordance with the practice and of E	A parto Quajro, 1000 C.D ,					
Disposition of Claims						
4)⊠ Claim(s) <u>1-11</u> is/are pending in the application.						
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>1-11</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers						
	r					
9) ☐ The specification is objected to by the Examiner. 10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119						
12) ☐ Acknowledgment is made of a claim for foreign a) ☐ All b) ☐ Some * c) ☐ None of:	priority under 35 U.S.C. § 119(a)-(d) or (f).				
1. ☐ Certified copies of the priority documents	s have been received.	,				
2. Certified copies of the priority documents		ion No				
Copies of the certified copies of the prior application from the International Bureau	rity documents have been receiv					
* See the attached detailed Office action for a list of the certified copies not received.						
Occ the attached detailed office detail for a field	o, the continue copies here e	·				
A44-2-k44-b						
Attachment(s)	4) 🔲 Interview Summary	(PTO-413)				
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 	Paper No(s)/Mail D					
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DETAILED ACTION

Response to Amendment

1. Amendment filed on 06/27/2005 has been entered and made of record as Paper No. 0605. In Amendment, claims 8-11 are newly added. Claims 1-11 are pending in the application.

Applicants' remarks have been considered.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-4 and 7 are rejected under 35 U.S.C. 103(a) as being unpatentable over Mukai et al (U.S. Pat No. 6,815,242 hereafter "Mukai")

Regarding claim 1 Mukai teaches a method of forming quantum dots, the method comprising: forming an $In_xGa_{1-x}As$ layer 136 on a buffer layer 132/134 (col. 17, lines 15-55 and Fig. 19A-19C); and forming In(Ga)As quantum dots 138 on the $In_xGa_{1-x}As$ layer 136 (col. 17, lines 15-55 and Figs. 19A-19C).

Mukai teaches the claimed invention except for the strained layer, It would have been obvious to a person of ordinary skill in the art at the time of the invention was made to use the In_xGa_{1-x}As layer 136 as a strained layer since it was known in the art that the In_xGa_{1-x}As layer 136 could be used to control the lattice constant of the surface

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of the buffer layer, therefore the quantum dots can be shifted to a longer wavelength as taught by Mukai, column 3, line 35 through column 4, line 15).

Regarding claim 2, Mukai teaches wherein the buffer layer 132/134 is made of InAIAs, InAIGaAs, InP, InGaAsP or is a hetrojunction layer of at least two of these four materials (col. 17, lines 28-32 and Fig. 19A).

Regarding claim 3, Mukai teaches wherein in the $In_xGa_{1-x}As$ layer 136, " x " is 0.05 -0.45 (col. 17, line 32 and Fig. 19A).

Regarding claim 4, Mukai teaches wherein the thickness of the $In_xGa_{1-x}As$ layer 136 is 100nm, but do not teach the thickness of the $In_xGa_{1-x}As$ layer 136 in a range of 0.5 nm - 10 nm (col. 17, line 20 and Fig. 19A).

In re Woodruff, 16 USPQ2d 1935, 1937 (Fed. Cir. 1990). See also In re Huang, 40 USPQ2d 1685, 1688 (Fed. Cir. 1996) (claimed ranges of a result effective variable, which do not overlap the prior art ranges, are unpatentable unless they produce a new and unexpected result which is different in kind and not merely in degree from the results of the prior art). See also In re Boesch, 205 USPQ 215 (CCPA) (discovery of optimum value of result effective variable in known process is ordinarily within skill of art) and In re Aller, 105 USPQ 233 (CCPA 1955) (selection of optimum ranges within prior art general conditions is obvious). It would have been obvious to one of ordinary skill in the art, at the time the invention was made, to use the optimum ranges for the g rate of the In_xGa_{1-x}As layer 136 in the method of Mukai et al.

Regarding claim 7, Mukai teaches wherein the $In_xGa_{1-x}As$ layer and the In(Ga)As quantum dots can be stacked 1 to 30 sets on top of one another (see fig. 7).

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4. Claims 5 and 6 are rejected under 35 U.S.C. 103(a) as being unpatentable over Mukai et al (U.S. Pat No. 6,815,242 hereafter "Mukai") in view of Petroff et al (U.S. Pat No. 5,614,435 hereafter "Petroff").

Mukai does not teach wherein In(Ga)As quantum dots are formed by metal organic chemical vapor depostion, molecular beam epitaxial, or chemical beam epitaxial.

Regarding claim 5, Petroff teaches teaches wherein In(Ga)As quantum dots are formed by metal organic chemical vapor depostion, molecular beam epitaxial, or chemical beam epitaxial (col. 7, lines 50-65). At the time of the invention was made, it would have been obvious to a person of ordinary skill in the art to combine the MOCVD teaching of Petroff with Mukai's MOVPE, because it would have provided a better formation of quantum dots on the substrate as taught by Petroff, column 7, lines 50-65.

Regarding claim 6, Petroff teaches wherein the thickness of the InGaAs quantum dots 38 is 3-10 monolayers (col. 8, lines 60-40 and Fig. 6e).

5. Claims 8-11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Mukai et al (U.S. Pat No. 6,815,242 hereafter "Mukai") in view of Shields et al (U.S. Pat No. 6,885,023 hereafter "Shields").

Regarding claim 8, Mukai teaches a method of forming quantum dots, the method comprising: forming a buffer layer 132/134 on a GaAs substrate 130 (col. 17, lines 15-55 and Fig. 19A-19C); forming an In_xGa_{1-x}As layer 136 on a buffer layer 132/134 (col. 17, lines 15-55 and Fig. 19A-19C); and forming In(Ga)As quantum dots 138 on the In_xGa_{1-x}As layer 136 (col. 17, lines 15-55 and Figs. 19A-19C). Mukai

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teaches the claimed invention except for wherein the InxGal-xAs strained layer changes the surface structure of the lattice- matched buffer layer and alters a strain energy that is necessary to grow the In(Ga)As quantum dots. It would have been obvious to a person of ordinary skill in the art at the time of the invention was made to use the In_xGa_{1-x}As layer 136 as a strained layer since it was known in the art that the In_xGa_{1-x}As layer 136 could be used to control the lattice constant of the surface of the

buffer layer, therefore the quantum dots can be shifted to a longer wavelength as taught

Mukai teaches the GaAs substrate, but does does not clearly teach the InP substrate

by Mukai, column 3, line 35 through column 4, line 15).

However, Shields teaches teach an InP substrate 33 is used (col. 15, lines 40-55 and Fig. 13). It would have been obvious to a person of ordinary skill in the art at the time of the invention was made to combine the InP substrate teaching of Shields with Mukai's device, because it would have provided a better matching between the substrate and an upper InAlAs buffer layer as taught by Shields, column 15, lines 40-55.

Regarding claim 9, Mukai teaches wherein the buffer layer 132/134 is made of InAIAs, InAIGaAs, InP, InGaAsP or is a hetrojunction layer of at least two of these four materials (col. 17, lines 28-32 and Fig. 19A).

Regarding claim 10, Mukai teaches wherein in the $In_xGa_{1-x}As$ layer 136, " x " is 0.05 -0.45 (col. 17, line 32 and Fig. 19A).

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Regarding claim 11, Mukai teaches wherein the thickness of the $ln_xGa_{1-x}As$ layer 136 is 100nm, but do not teach the thickness of the $ln_xGa_{1-x}As$ layer 136 in a range of 0.5 nm - 10 nm (col. 17, line 20 and Fig. 19A).

In re Woodruff, 16 USPQ2d 1935, 1937 (Fed. Cir. 1990). See also In re Huang, 40 USPQ2d 1685, 1688 (Fed. Cir. 1996) (claimed ranges of a result effective variable, which do not overlap the prior art ranges, are unpatentable unless they produce a new and unexpected result which is different in kind and not merely in degree from the results of the prior art). See also In re Boesch, 205 USPQ 215 (CCPA) (discovery of optimum value of result effective variable in known process is ordinarily within skill of art) and In re Aller, 105 USPQ 233 (CCPA 1955) (selection of optimum ranges within prior art general conditions is obvious). It would have been obvious to one of ordinary skill in the art, at the time the invention was made, to use the optimum ranges for the g rate of the In_xGa_{1-x}As layer 136 in the method of Mukai et al.

Response to Arguments

6. Applicant's arguments filed 06/27/2005 have been fully considered but they are not persuasive.

In response to applicant's argument that the Mukai fails to teach or suggest that the InGaAs layer 136 is not formed on the buffer layer 132/134. The examiner disagrees. Clearly in column 17 lines 15-45 and figure 19B, the InGaAs layer 136 is formed on the buffer layer 132/134.

Conclusion

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7. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quoc Hoang whose telephone number is (571) 272-1780. The examiner can normally be reached on Monday-Friday from 8.00 AM to 5.00 PM.

If attempt to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers of the organization where this application or proceeding is assigned are (703) 872-9306 for regular communications and (703) 872-9306 for After Final communications.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-

0956.

dy

Quoc Hoang Patent examiner/AU 2818

Dévid Nelms
Supervisory Patent Examiner
Technology Center 2800